

PTO-1449

Application No.

Applicant(s)

10/678,837

Tomblad et al.

**Information Disclosure Citation
in an Application**

Docket Number

Group Art Unit

Filing Date

068736.0231

2811

October 3, 2003

MAY 09 2005

U.S. PATENT DOCUMENTS

| | DOCUMENT NO. | DATE | NAME | CLASS | SUBCLASS | FILING DATE |
|----|--------------|---------|--------------|------------|-------------|-------------|
| A. | 5132753 | 7/21/92 | Chang et al. | 257 357 | 655 23.4 | 3/23/90 |
| B. | 6613622 | 9/2/03 | Nair et al. | 438 | 188 | 7/15/02 |
| C. | | | | | | |
| D. | | | | | | |
| E. | | | | | | |
| F. | | | | | | |
| G. | | | | | | |
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| M. | | | | | | |
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| O. | | | | | | |

FOREIGN PATENT DOCUMENTS

| | DOCUMENT NO. | DATE | COUNTRY | CLASS | SUBCLASS | TRANSLATION | |
|----|--------------|------|---------|-------|----------|-------------|----|
| | | | | | | YES | NO |
| P. | | | | | | | |
| Q. | | | | | | | |
| R. | | | | | | | |
| S. | | | | | | | |
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| U. | | | | | | | |

NON-PATENT DOCUMENTS - DOCUMENT (Including Author, Title, Source, and Pertinent Pages)

| | | |
|----|---|---------|
| V. | Dragon et al., "A Silicon MOS Process for Integrated RF Power Amplifiers," IEEE MTT-S Digest, Pages 257-260 | 6/17/96 |
| W. | | |
| X. | | |
| Y. | | |
| Z. | | |

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.